



IPW 2814

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of:

Gu-Sung KIM

Art Unit: 2814

Serial No. 10/073,173

Examiner: Long Pham

Filed: February 13, 2002

Confirmation No. 4677

For: WAFER LEVEL PACKAGE WITH AIR
PADS AND MANUFACTURING METHOD
THEREOF

Attorney Docket No. 259/014

AMENDMENT UNDER 37 C.F.R. § 1.111

Mail Stop Amendment
Commissioner for Patents
United States Patent and Trademark Office
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

INTRODUCTORY COMMENTS

In response to the outstanding Office action, mailed August 23, 2005, the following amendments and remarks are respectfully submitted in connection with the above-identified application:

Amendments to the Claims are reflected in a listing of claims, which begins on page 2 of this paper.

Remarks begin on page 6 of this paper.